



INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		Attorney Docket No.: 46884-5461	Serial No.: 10/571,142
PTO Form 1449		Applicants Kenshi FUKUMITSU et al.	Page 1 of 6
		Filing Date: March 9, 2006	Group Art Unit: 2811

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		08-197271	Aug. 6, 1996	Japan			Abstract
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		WO 03/076118	Sep. 18, 2003	Japan			Abstract
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		JP 4-188847	July 7, 1992	Japan			Abstract
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		"Stealth Dicing, It's Principles and Features: A Technology Most Suitable for Dicing Very Thin Semiconductor Wafers" published by Takaoka Hidetsugu, Electronic Material No. 9, 2002, pp. 17-21, including English language translation					
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